



DEP # REF
Room 307

Docket No.: 50090-334

STATUS AND ENTRY
BRANCH

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Masanobu IWASAKI, et al.

Serial No.: 09/934,474

Filed: August 23, 2001

Customer Number: 20277

Confirmation Number:

Group Art Unit: 3723

Examiner: H. Shakeri

#181 Reg for
Refund
06-01-04

For: POLISHING SOLUTION SUPPLY SYSTEM, METHOD OF SUPPLYING POLISHING
SOLUTION, APPARATUS FOR AND METHOD OF POLISHING SEMICONDUCTOR SUBSTRATE
AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

REQUEST FOR REFUND

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A refund in the amount of \$410.00 is hereby requested in the above-identified application for the following reason:

A Response to the Order Returning Undocketed Appeal to Examiner was filed on November 17, 2003. No Request for Extension of Time was required for this response. Please refer to the copy of the USPTO Pair Page attached. Please note that no other papers were filed that required Requests for Extension of Time. The fee of \$410.00 was erroneously charged on February 12, 2004 under Control No. 5.

Please immediately credit Deposit Account number 500417 in this amount.

Adjustment date: 06/02/2004 EEKURAY1
02/18/2004 ECOLBERT 00000005 500417 09934474
01 FC:2252 410.00 CR

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Arthur J. Steiner
Registration No. 26,106

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 AJS/lrd
Facsimile: (202) 756-8087
Date: April 26, 2004



United States Patent and Trademark Office

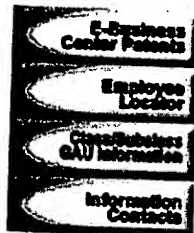
Home | Site Index | Search | Guides | Contacts | eBusiness | eBiz and ePolicies | ePolicies | ePolicies



PATENT APPLICATION INFORMATION RETRIEVAL



Other Links



Search results for application number:09/934,474			
Application Number:	09/934,474	Customer Number:	-
Filing or 371(c) Date:	08-23-2001	Status:	Reply Brief Noted Examiner
Application Type:	Utility	Status Date:	03-17-2003
Examiner Name:	SHAKERI, HADI	Location:	TC 3700 CENTRAL CP2-10C25
Group Art Unit:	3723	Location Date:	04-08-2004
Confirmation Number:	8431	Earliest Publication No:	US 2002-0065022 /
Attorney Docket Number:	50090-334	Earliest Publication Date:	05-30-2002
Class/ Sub-Class:	451/041	Patent Number:	-
First Named Inventor:	Masanobu Iwasaki, Tokyo, (JP)	Issue Date of Patent:	-
Title Of Invention:	Polishing solution supply system, method of supplying polishing solution, apparatus for and method of polishing semiconductor substrate and method of manufacturing semiconductor device		

Select Search Option

Published Documents ☐

Search

File History		
Number	Date	Contents Description
36	04-07-2004	Mail Miscellaneous Communication to Applicant
35	04-06-2004	Miscellaneous Communication to Applicant - No Action Count
34	11-17-2003	Miscellaneous Incoming Letter
33	11-17-2003	Miscellaneous Incoming Letter
32	10-02-2003	Appeal Awaiting BPAI Docketing
31	05-20-2003	Order Returning Undocketed Appeal to the Examiner
30	04-22-2003	Appeal Awaiting BPAI Docketing
29	03-18-2003	Mail Reply Brief Noted by Examiner
28	03-17-2003	Reply Brief Noted by Examiner
27	01-27-2003	Date Forwarded to Examiner
26	01-22-2003	Reply Brief Filed
25	11-22-2002	Mail Examiner's Answer
24	11-21-2002	Examiner's Answer to Appeal Brief
23	11-14-2002	Date Forwarded to Examiner

22	11-04-2002	Appeal Brief Filed
21	09-04-2002	Notice of Appeal Filed
20	09-04-2002	Request for Extension of Time - Granted
19	07-28-2002	Mail Advisory Action (PTOL - 303)
18	07-28-2002	Advisory Action (PTOL - 303)
17	07-25-2002	Date Forwarded to Examiner
16	07-18-2002	Amendment after Final Rejection
15	04-18-2002	Mail Final Rejection (PTOL - 326)
14	04-16-2002	Final Rejection
13	03-13-2002	Date Forwarded to Examiner
12	03-04-2002	Response after Non-Final Action
11	12-04-2001	Mail Non-Final Rejection
10	11-28-2001	Non-Final Rejection
9	08-23-2001	Request for Foreign Priority (Priority Papers May Be Included)
8	08-23-2001	Information Disclosure Statement (IDS) Filed
7	10-29-2001	Case Docketed to Examiner in GAU
6	10-01-2001	Application Dispatched from OIPE
5	09-28-2001	Correspondence Address Change
4	09-28-2001	Correspondence Address Change
3	09-27-2001	Correspondence Address Change
2	08-29-2001	FW Scan & PACR Auto Security Review
1	08-23-2001	Initial Exam Team nn

[|.HOME](#) | [INDEX](#) | [SEARCH](#) | [eBUSINESS](#) | [CONTACT US](#) | [PRIVACY STATEMENT](#)